

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|----------|------------------|---------|------------------|
| L1 | 0 | (film bulk acoustic wave AND substrate AND protective film AND reflective layer AND etch protection thermal oxidation AND piezoelectric). CLM. | US-PGPUB | AND | OFF | 2007/11/26 07:54 |